



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroaki TAKAIWA

Group Art Unit: 2851

Application No.: 10/589,665

Examiner: M. LIU

Filed: August 16, 2006

Docket No.: 129125

For: EXPOSURE APPARATUS PREVENTING GAS FROM MOVING FROM EXPOSURE
REGION TO MEASUREMENT REGION (as amended)

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the April 1, 2009 Office Action, the shortened statutory period for reply
being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.